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PATENT

#12/Response

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Hidemi Takasu

Serial No.: 09/212,915

Examiner: M. Estrada

Filed : December 16, 1998

Group Art Unit: 2823

For : PROCESS FOR FABRICATING A
SEMICONDUCTOR DRIVEREQUEST FOR RECONSIDERATION

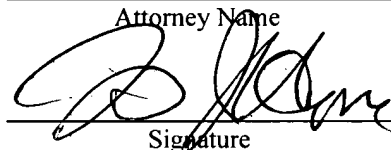
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Date of Deposit

Francis J. Hone

Attorney Name



Signature

18,662

PTO Reg. No.

November 13, 2001

Date of Signature

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

In response to the Examiner's Action mailed August 13, 2001 the following
remarks are submitted:

R E M A R K S

The Examiner's rejection of claims 1 and 3-9 as being unpatentable over the
Japanese Patent Publication No. 63-261833, in combination with the Wolf publication